

L Number	Hits	Search Text	D8	Time stamp
1	369	((heat\$3 adj (section or zone or chamber)) and (react\$3 adj (section or zone or chamber)) and puls\$3 and (nozzle or inject\$3 or inlet)) not (((422/198,194,190,110).CCLS.) and heat\$3 and puls\$3) (((422/198,194,190,110).CCLS.) and heat\$3 and puls\$3) not (((422/129,139,145,146,147) or (118/716)).CCLS.) and heat\$3) and puls\$3) (((422/198,194,190,110).CCLS.) or (((422/129,139,145,146,147) or (118/716)).CCLS.) and (silicon near granule)) (((422/129,139,145,146,147) or (118/716)).CCLS.) and heat\$3) and puls\$3) (((422/198,194,190,110).CCLS.) or (((422/129,139,145,146,147) or (118/716)).CCLS.) and (silicon) and heat\$3) not (((422/198,194,190,110).CCLS.) and heat\$3 and puls\$3) not (((422/129,139,145,146,147) or (118/716)).CCLS.) and heat\$3) (((422/198,194,190,110).CCLS.) or (((422/129,139,145,146,147) or (118/716)).CCLS.) and (silicon near granule)) (((422/129,139,145,146,147) or (118/716)).CCLS.) and heat\$3) and puls\$3)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TD8	2004/01/08 10:15
2	58	((heat\$3 adj (section or zone or chamber)) and (react\$3 adj (section or zone or chamber)) and puls\$3 and (nozzle or inject\$3 or inlet)) not (((422/198,194,190,110).CCLS.) and heat\$3 and puls\$3) (((422/198,194,190,110).CCLS.) and heat\$3 and puls\$3) not (((422/129,139,145,146,147) or (118/716)).CCLS.) and heat\$3) and puls\$3) (((422/198,194,190,110).CCLS.) or (((422/129,139,145,146,147) or (118/716)).CCLS.) and (silicon near granule)) (((422/129,139,145,146,147) or (118/716)).CCLS.) and heat\$3) and puls\$3) (((422/198,194,190,110).CCLS.) or (((422/129,139,145,146,147) or (118/716)).CCLS.) and (silicon) and heat\$3) not (((422/198,194,190,110).CCLS.) and heat\$3 and puls\$3) not (((422/129,139,145,146,147) or (118/716)).CCLS.) and heat\$3) and puls\$3) (((422/198,194,190,110).CCLS.) or (((422/129,139,145,146,147) or (118/716)).CCLS.) and (silicon near granule)) (((422/129,139,145,146,147) or (118/716)).CCLS.) and heat\$3) and puls\$3))) not ((heat\$3 adj (section or zone or chamber)) and (react\$3 adj (section or zone or chamber)) and puls\$3 and (gas same (nozzle or inject\$3 or inlet))) not (((422/198,194,190,110).CCLS.) and heat\$3 and puls\$3) (((422/198,194,190,110).CCLS.) and heat\$3 and puls\$3) not (((422/129,139,145,146,147) or (118/716)).CCLS.) and heat\$3) and puls\$3) (((422/198,194,190,110).CCLS.) or (((422/129,139,145,146,147) or (118/716)).CCLS.) and (silicon near granule)) (((422/129,139,145,146,147) or (118/716)).CCLS.) and heat\$3) and puls\$3) (((422/198,194,190,110).CCLS.) or (((422/129,139,145,146,147) or (118/716)).CCLS.) and (silicon) and heat\$3) not (((422/198,194,190,110).CCLS.) and heat\$3 and puls\$3) not (((422/129,139,145,146,147) or (118/716)).CCLS.) and heat\$3) and puls\$3) (((422/198,194,190,110).CCLS.) or (((422/129,139,145,146,147) or (118/716)).CCLS.) and (silicon near granule)) (((422/129,139,145,146,147) or (118/716)).CCLS.) and heat\$3) and puls\$3)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TD8	2004/01/08 10:16
3	4	((heat\$3 adj (section or zone or chamber)) and (react\$3 adj (section or zone or chamber)) and puls\$3 and ((nozzle or inject\$3 or inlet)) and (silicon near granule))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TD8	2004/01/08 10:25

	2838	((422/129,139,145,146,147) or (118/716)).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/07 09:46
	1409	(((422/129,139,145,146,147) or (118/716)).CCLS.) and heat\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/06 17:38
	94	(((422/129,139,145,146,147) or (118/716)).CCLS.) and heat\$3) and puls\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/07 10:59
	2	("20020081250").PN.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/06 18:18
	3254	(422/198,194,190,110).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/07 09:00
	92	((422/198,194,190,110).CCLS.) and heat\$3 and puls\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/07 09:01
	87	(((422/198,194,190,110).CCLS.) and heat\$3 and puls\$3) not (((422/129,139,145,146,147) or (118/716)).CCLS.) and heat\$3) and puls\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/07 09:01
	2838	((422/129,139,145,146,147) or (118/716)).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/07 09:46
	8	(((422/198,194,190,110).CCLS.) or (((422/129,139,145,146,147) or (118/716)).CCLS.)) and (silicon near granule)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/07 13:39
	439	(((422/198,194,190,110).CCLS.) or (((422/129,139,145,146,147) or (118/716)).CCLS.)) and (silicon)) not (((422/198,194,190,110).CCLS.) or (((422/129,139,145,146,147) or (118/716)).CCLS.)) and (silicon near granule))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/07 11:01
	94	(((422/129,139,145,146,147) or (118/716)).CCLS.) and heat\$3) and puls\$3	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/01/07 10:59

	324	(((422/198,194,190,110).CCLS.) or (((422/129,139,145,146,147) or (118/716)).CCLS.) and (silicon) and heat\$3) not (((422/198,194,190,110).CCLS.) and heat\$3 and puls\$3) not (((422/129,139,145,146,147) or (118/716)).CCLS.) and heat\$3 and puls\$3) (((422/198,194,190,110).CCLS.) or (((422/129,139,145,146,147) or (118/716)).CCLS.) and (silicon near granule)) (((422/129,139,145,146,147) or (118/716)).CCLS.) and heat\$3 and puls\$3))	USPAT; US-PGPUB; EPO; JPO; DERWENT; ISM_TDB	2004/01/07 12:39
	319	((heat\$3 adj (section or zone or chamber)) and (react\$3 adj (section or zone or chamber)) and puls\$3 and (gas same (nozzle or inject\$3 or inlet)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; ISM_TDB	2004/01/07 12:47
	311	((heat\$3 adj (section or zone or chamber)) and (react\$3 adj (section or zone or chamber)) and puls\$3 and (gas same (nozzle or inject\$3 or inlet))) not (((422/198,194,190,110).CCLS.) and heat\$3 and puls\$3) (((422/198,194,190,110).CCLS.) and heat\$3 and puls\$3) not (((422/129,139,145,146,147) or (118/716)).CCLS.) and heat\$3 and puls\$3) (((422/129,139,145,146,147) or (118/716)).CCLS.) and (silicon near granule)) (((422/129,139,145,146,147) or (118/716)).CCLS.) and heat\$3 and puls\$3) (((422/198,194,190,110).CCLS.) or (((422/129,139,145,146,147) or (118/716)).CCLS.) and (silicon) and heat\$3) not (((422/198,194,190,110).CCLS.) and heat\$3 and puls\$3) not (((422/129,139,145,146,147) or (118/716)).CCLS.) and heat\$3 and puls\$3) (((422/198,194,190,110).CCLS.) or (((422/129,139,145,146,147) or (118/716)).CCLS.) and (silicon near granule)) (((422/129,139,145,146,147) or (118/716)).CCLS.) and heat\$3 and puls\$3)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; ISM_TDB	2004/01/08 10:15
4		((heat\$3 adj (section or zone or chamber)) and (react\$3 adj (section or zone or chamber)) and puls\$3 and (gas same (nozzle or inject\$3 or inlet))) and (silicon near granule)	USPAT; US-PGPUB; EPO; JPO; DERWENT; ISM_TDB	2004/01/08 10:24